

**RADIATION HARDENED  
POWER MOSFET  
SURFACE MOUNT (SMD-0.5)**
**100V, N-CHANNEL**
**R<sub>6</sub> TECHNOLOGY**

**Product Summary**

Part Number	Radiation Level	RDS(on)	I <sub>D</sub>
IRHNJ6S7130	100 kRads(Si)	0.042Ω	22A*
IRHNJ6S3130	300 kRads(Si)	0.042Ω	22A*

**Description**

IR HiRel R6 S-line technology provides high performance power MOSFETs for space applications. These devices have been characterized for both Total Dose and Single Event Effect (SEE) with useful performance up to LET of 60 (MeV/(mg/cm<sup>2</sup>)). The combination of low RDS(on) and low gate charge reduces the power losses in switching applications such as DC-DC converters and motor controllers. These devices retain all of the well established advantages of MOSFETs such as voltage control, fast switching, ease of paralleling and temperature stability of electrical parameters.

**Features**

- Single Event Effect (SEE) Hardened
- Low RDS(on)
- Low Total Gate Charge
- Simple Drive Requirements
- Ease of Paralleling
- Hermetically Sealed
- Electrically Isolated
- Ceramic Package
- Light Weight
- Surface Mount
- ESD Rating: Class 2 per MIL-STD-750, Method 1020

**Absolute Maximum Ratings**
**Pre-Irradiation**

	Parameter		Units
I <sub>D</sub> @ V <sub>GS</sub> = 12V, T <sub>C</sub> = 25°C	Continuous Drain Current	22*	A
I <sub>D</sub> @ V <sub>GS</sub> = 12V, T <sub>C</sub> = 100°C	Continuous Drain Current	19	
I <sub>DM</sub>	Pulsed Drain Current ①	88	
P <sub>D</sub> @T <sub>C</sub> = 25°C	Maximum Power Dissipation	75	W
	Linear Derating Factor	0.6	W/°C
V <sub>GS</sub>	Gate-to-Source Voltage	±20	V
E <sub>AS</sub>	Single Pulse Avalanche Energy ②	73	mJ
I <sub>AR</sub>	Avalanche Current ①	22	A
E <sub>AR</sub>	Repetitive Avalanche Energy ①	7.5	mJ
dv/dt	Peak Diode Recovery dv/dt ③	3.8	V/ns
T <sub>J</sub> T <sub>STG</sub>	Operating Junction and Storage Temperature Range	-55 to + 150	°C
	Lead Temperature	300 (for 5s)	
	Weight	1.0 (Typical)	g

For Footnotes, refer to the page 2.

### Electrical Characteristics @ $T_J = 25^\circ\text{C}$ (Unless Otherwise Specified)

	Parameter	Min.	Typ.	Max.	Units	Test Conditions
$\text{BV}_{\text{DSS}}$	Drain-to-Source Breakdown Voltage	100	—	—	V	$\text{V}_{\text{GS}} = 0\text{V}$ , $I_D = 1.0\text{mA}$
$\Delta \text{BV}_{\text{DSS}}/\Delta T_J$	Breakdown Voltage Temp. Coefficient	—	0.11	—	V/ $^\circ\text{C}$	Reference to $25^\circ\text{C}$ , $I_D = 1.0\text{mA}$
$R_{\text{DS(on)}}$	Static Drain-to-Source On-	—	—	0.042	$\Omega$	$\text{V}_{\text{GS}} = 12\text{V}$ , $I_D = 19\text{A}$ ④
$\text{V}_{\text{GS(th)}}$	Gate Threshold Voltage	2.0	—	4.0	V	$\text{V}_{\text{DS}} = \text{V}_{\text{GS}}$ , $I_D = 1.0\text{mA}$
$\Delta \text{V}_{\text{GS(th)}}/\Delta T_J$	Gate Threshold Voltage Coefficient	—	-8.83	—	mV/ $^\circ\text{C}$	
$g_{\text{fs}}$	Forward Transconductance	14	—	—	S	$\text{V}_{\text{DS}} = 15\text{V}$ , $I_D = 19\text{A}$ ④
$I_{\text{DSS}}$	Zero Gate Voltage Drain Current	—	—	10	$\mu\text{A}$	$\text{V}_{\text{DS}} = 80\text{V}$ , $\text{V}_{\text{GS}} = 0\text{V}$
		—	—	25	$\mu\text{A}$	$\text{V}_{\text{DS}} = 80\text{V}$ , $\text{V}_{\text{GS}} = 0\text{V}$ , $T_J = 125^\circ\text{C}$
$I_{\text{GSS}}$	Gate-to-Source Leakage Forward	—	—	100	nA	$\text{V}_{\text{GS}} = 20\text{V}$
	Gate-to-Source Leakage Reverse	—	—	-100	nA	$\text{V}_{\text{GS}} = -20\text{V}$
$Q_G$	Total Gate Charge	—	—	50	nC	$I_D = 22\text{A}$
$Q_{\text{GS}}$	Gate-to-Source Charge	—	—	15		$\text{V}_{\text{DS}} = 50\text{V}$
$Q_{\text{GD}}$	Gate-to-Drain ('Miller') Charge	—	—	20		$\text{V}_{\text{GS}} = 12\text{V}$
$t_{\text{d(on)}}$	Turn-On Delay Time	—	—	25	ns	$\text{V}_{\text{DD}} = 50\text{V}$
$t_r$	Rise Time	—	—	30		$I_D = 22\text{A}$
$t_{\text{d(off)}}$	Turn-Off Delay Time	—	—	60		$R_G = 7.5\Omega$
$t_f$	Fall Time	—	—	30		$\text{V}_{\text{GS}} = 12\text{V}$
$L_s + L_D$	Total Inductance	—	4.0	—	nH	Measured from center of Drain pad to center of Source pad
$C_{\text{iss}}$	Input Capacitance	—	1730	—	pF	$\text{V}_{\text{GS}} = 0\text{V}$
$C_{\text{oss}}$	Output Capacitance	—	340	—		$\text{V}_{\text{DS}} = 25\text{V}$
$C_{\text{rss}}$	Reverse Transfer Capacitance	—	6.0	—		$f = 1.0\text{MHz}$
$R_G$	Gate Resistance	—	1.03	—	$\Omega$	$f = 1.0\text{MHz}$ , open drain

### Source-Drain Diode Ratings and Characteristics

	Parameter	Min.	Typ.	Max.	Units	Test Conditions
$I_S$	Continuous Source Current (Body Diode)	—	—	22*	A	
$I_{\text{SM}}$	Pulsed Source Current (Body Diode) ①	—	—	88		
$\text{V}_{\text{SD}}$	Diode Forward Voltage	—	—	1.2	V	$T_J = 25^\circ\text{C}$ , $I_S = 22\text{A}$ , $\text{V}_{\text{GS}} = 0\text{V}$ ④
$t_{\text{rr}}$	Reverse Recovery Time	—	—	350	ns	$T_J = 25^\circ\text{C}$ , $I_F = 22\text{A}$ , $\text{V}_{\text{DD}} \leq 25\text{V}$ $dI/dt = 100\text{A}/\mu\text{s}$ ④
$Q_{\text{rr}}$	Reverse Recovery Charge	—	—	3.0		
$t_{\text{on}}$	Forward Turn-On Time	Intrinsic turn-on time is negligible (turn-on is dominated by $L_s + L_D$ )				

### Thermal Resistance

	Parameter	Min.	Typ.	Max.	Units
$R_{\theta\text{JC}}$	Junction-to-Case	—	—	1.67	$^\circ\text{C/W}$

### Footnotes:

- ① Repetitive Rating; Pulse width limited by maximum junction temperature.
- ②  $\text{V}_{\text{DD}} = 25\text{V}$ , starting  $T_J = 25^\circ\text{C}$ ,  $L = 0.3\text{mH}$ , Peak  $I_L = 22\text{A}$ ,  $\text{V}_{\text{GS}} = 12\text{V}$
- ③  $I_{\text{SD}} \leq 22\text{A}$ ,  $dI/dt \leq 420\text{A}/\mu\text{s}$ ,  $\text{V}_{\text{DD}} \leq 100\text{V}$ ,  $T_J \leq 150^\circ\text{C}$
- ④ Pulse width  $\leq 300\ \mu\text{s}$ ; Duty Cycle  $\leq 2\%$
- ⑤ Total Dose Irradiation with  $\text{V}_{\text{GS}}$  Bias. 12 volt  $\text{V}_{\text{GS}}$  applied and  $\text{V}_{\text{DS}} = 0$  during irradiation per MIL-STD-750, Method 1019, condition A.
- ⑥ Total Dose Irradiation with  $\text{V}_{\text{DS}}$  Bias. 80 volt  $\text{V}_{\text{DS}}$  applied and  $\text{V}_{\text{GS}} = 0$  during irradiation per MIL-STD-750, Method 1019, condition A.

## Radiation Characteristics

IR HiRel radiation hardened MOSFETs are tested to verify their radiation hardness capability. The hardness assurance program at IR Hiresl is comprised of two radiation environments. Every manufacturing lot is tested for total ionizing dose (per notes 5 and 6) using the TO-3 package. Both pre- and post-irradiation performance are tested and specified using the same drive circuitry and test conditions in order to provide a direct comparison.

**Table1. Electrical Characteristics @  $T_j = 25^\circ\text{C}$ , Post Total Dose Irradiation ⑤⑥**

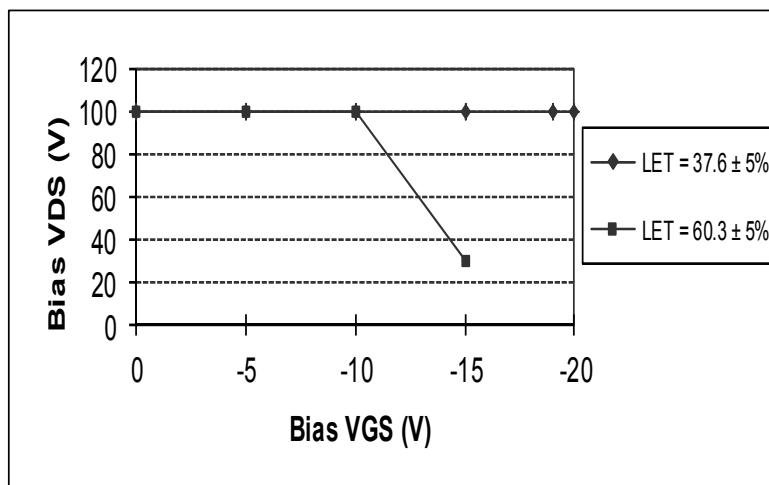
	Parameter	Up to 300 kRads (Si) <sup>1</sup>		Units	Test Conditions
		Min.	Max.		
$\text{BV}_{\text{DSS}}$	Drain-to-Source Breakdown Voltage	100	—	V	$\text{V}_{\text{GS}} = 0\text{V}$ , $\text{I}_D = 1.0\text{mA}$
$\text{V}_{\text{GS(th)}}$	Gate Threshold Voltage	2.0	4.0	V	$\text{V}_{\text{DS}} = \text{V}_{\text{GS}}$ , $\text{I}_D = 1.0\text{mA}$
$\text{I}_{\text{GSS}}$	Gate-to-Source Leakage Forward	—	100	nA	$\text{V}_{\text{GS}} = 20\text{V}$
$\text{I}_{\text{GSS}}$	Gate-to-Source Leakage Reverse	—	-100	nA	$\text{V}_{\text{GS}} = -20\text{V}$
$\text{I}_{\text{DSS}}$	Zero Gate Voltage Drain Current	—	10	$\mu\text{A}$	$\text{V}_{\text{DS}} = 80\text{V}$ , $\text{V}_{\text{GS}} = 0\text{V}$
$\text{R}_{\text{DS(on)}}$	Static Drain-to-Source ④ On-State Resistance (TO-3)	—	0.045	$\Omega$	$\text{V}_{\text{GS}} = 12\text{V}$ , $\text{I}_D = 19\text{A}$
$\text{R}_{\text{DS(on)}}$	Static Drain-to-Source ④ On-State Resistance (SMD-2)	—	0.042	$\Omega$	$\text{V}_{\text{GS}} = 12\text{V}$ , $\text{I}_D = 19\text{A}$
$\text{V}_{\text{SD}}$	Diode Forward Voltage ④	—	1.2	V	$\text{V}_{\text{GS}} = 0\text{V}$ , $\text{I}_D = 22\text{A}$

1. Part numbers IRHNJ6S7130 and IRHNJ6S3130

IR HiRel radiation hardened MOSFETs have been characterized in heavy ion environment for Single Event Effects (SEE). Single Event Effects characterization is illustrated in Fig. a and Table 2.

**Table 2. Typical Single Event Effect Safe Operating Area**

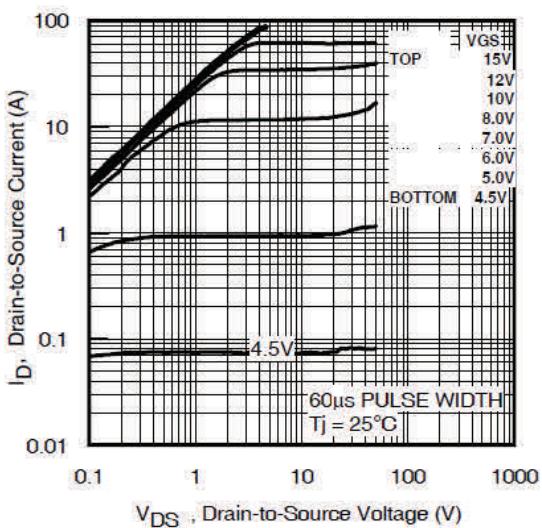
LET (MeV/(mg/cm <sup>2</sup> ))	Energy (MeV)	Range ( $\mu\text{m}$ )	V <sub>DS</sub> (V)					
			@ V <sub>GS</sub> = 0V	@ V <sub>GS</sub> = -5V	@ V <sub>GS</sub> = -10V	@ V <sub>GS</sub> = -15V	@ V <sub>GS</sub> = -19V	@ V <sub>GS</sub> = -20V
37.6 ± 5%	391 ± 5%	47.6 ± 5%	100	100	100	100	100	100
60.3 ± 5%	711 ± 5%	57.7 ± 7.5%	100	100	100	30	—	—



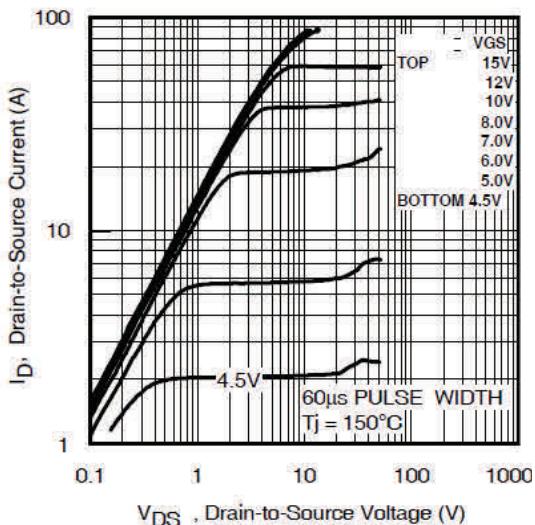
**Fig a.** Typical Single Event Effect, Safe Operating Area

For Footnotes, refer to the page 2.

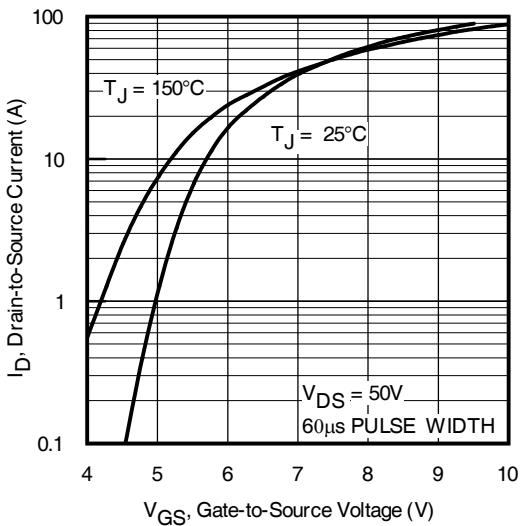
**Pre-Irradiation**



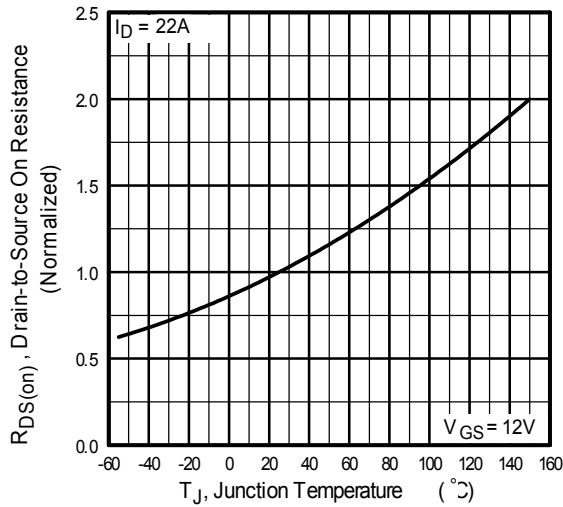
**Fig 1.** Typical Output Characteristics



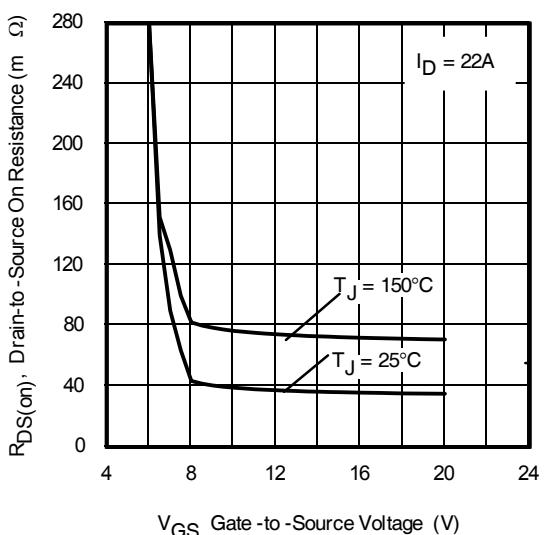
**Fig 2.** Typical Output Characteristics



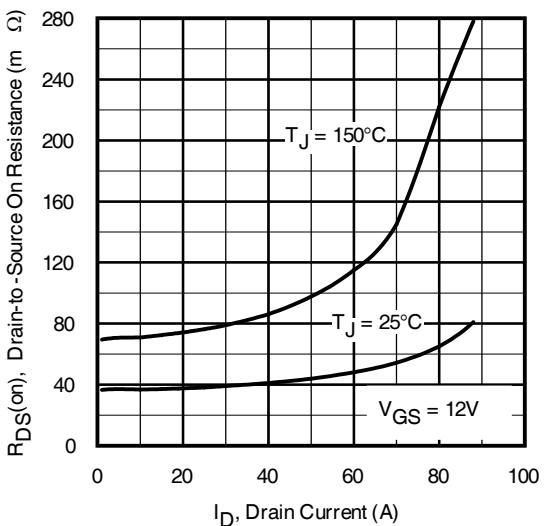
**Fig 3.** Typical Transfer Characteristics



**Fig 4.** Normalized On-Resistance Vs. Temperature

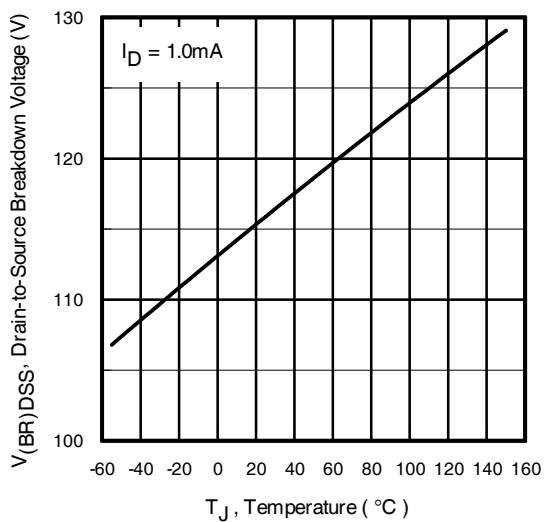


**Fig 5.** Typical On-Resistance Vs Gate Voltage

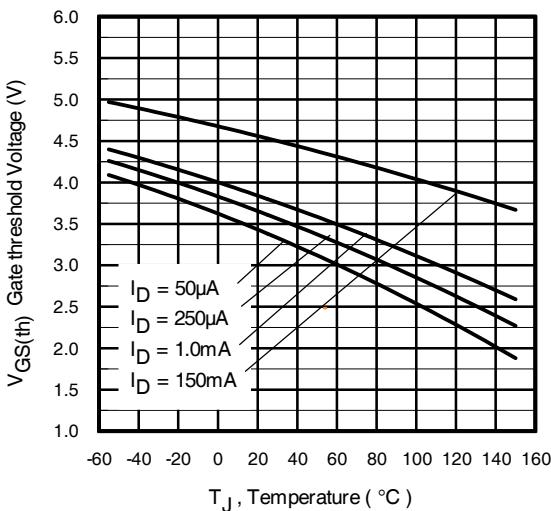


**Fig 6.** Typical On-Resistance Vs Drain Current

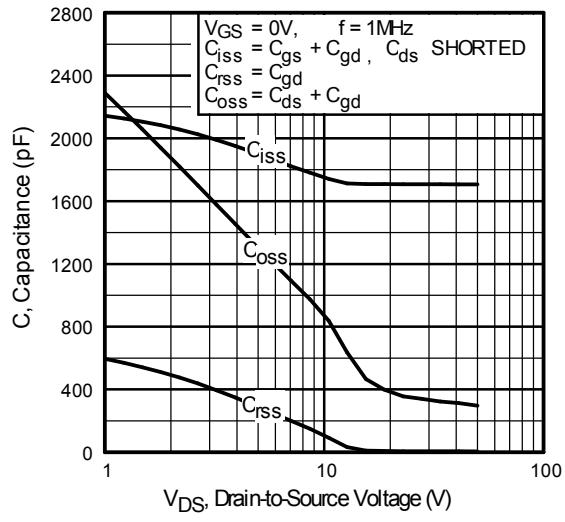
**Pre-Irradiation**



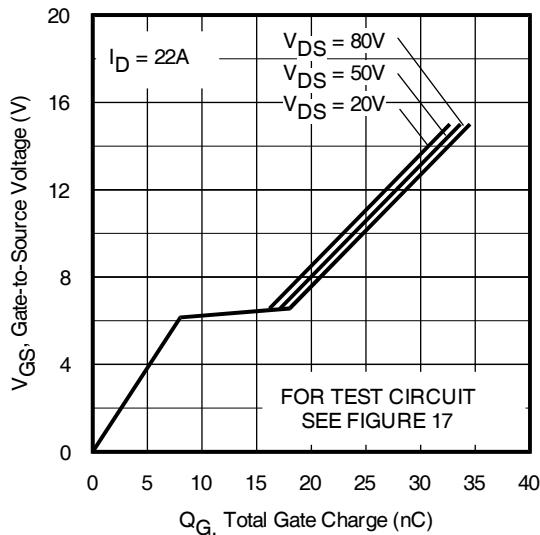
**Fig 7.** Typical Drain-to-Source Breakdown Voltage Vs Temperature



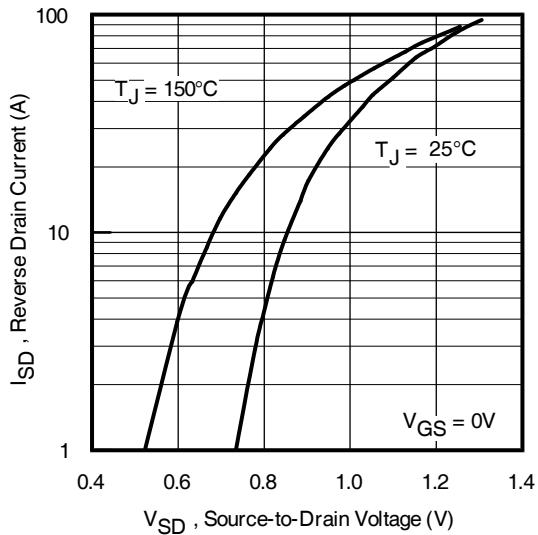
**Fig 8.** Typical Threshold Voltage Vs Temperature



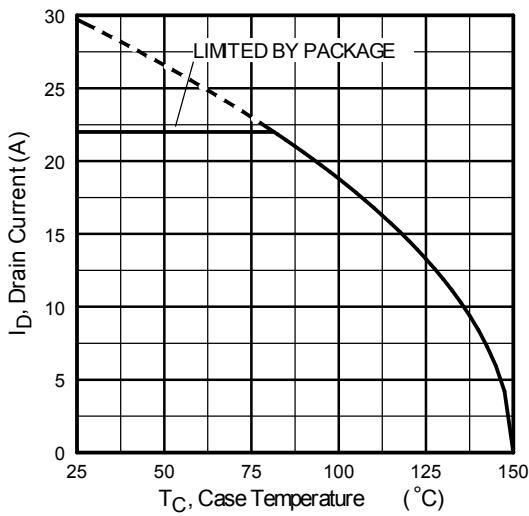
**Fig 9.** Typical Capacitance Vs. Drain-to-Source Voltage



**Fig 10.** Typical Gate Charge Vs. Gate-to-Source Voltage

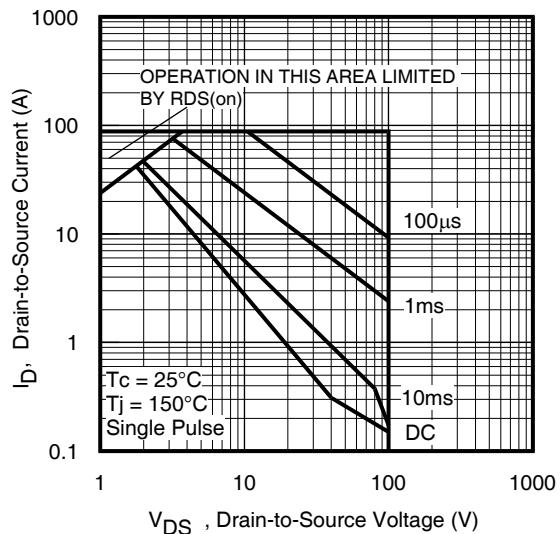


**Fig 11.** Typical Source-Drain Diode Forward Voltage

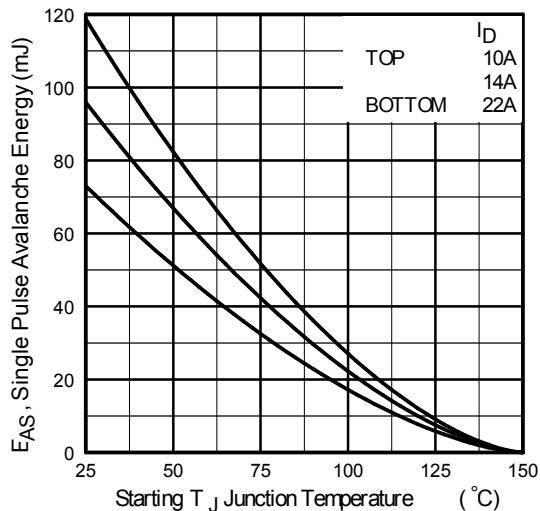


**Fig 12.** Maximum Drain Current Vs. Case Temperature

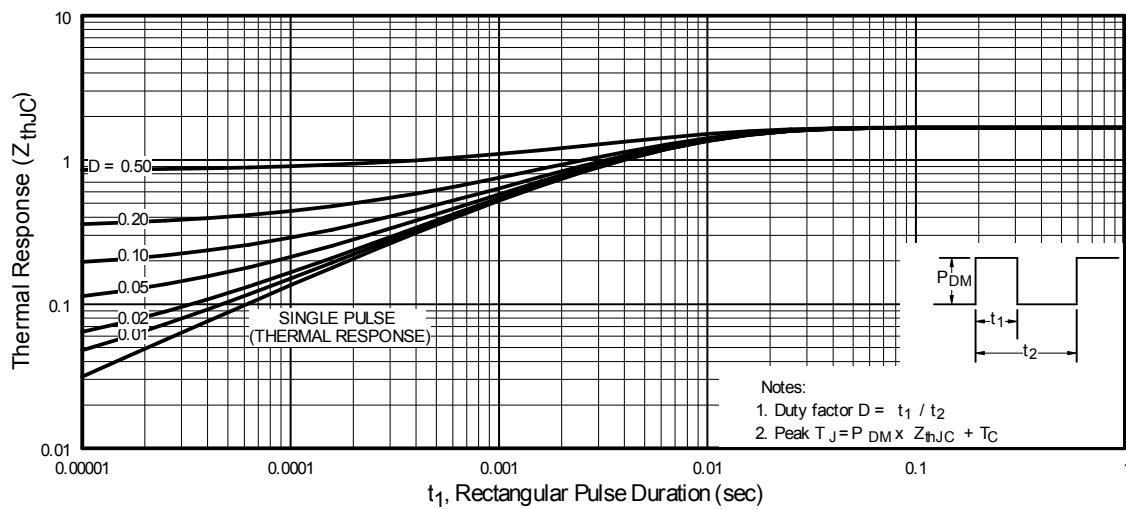
**Pre-Irradiation**



**Fig 13.** Maximum Safe Operating Area



**Fig 14.** Maximum Avalanche Energy Vs. Drain Current



**Fig**

Pre-Irradiation

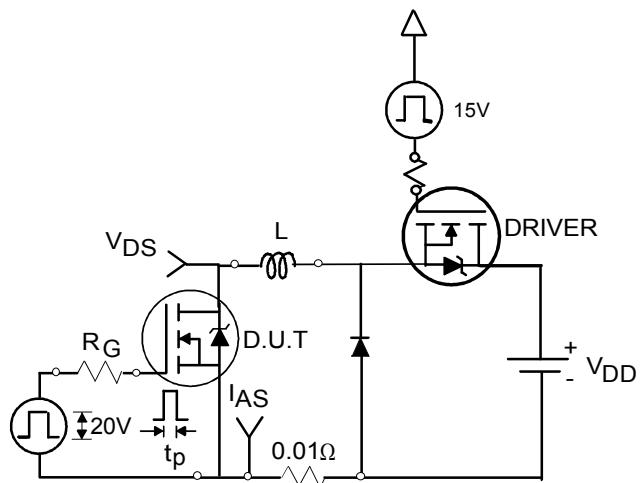


Fig 16a. Unclamped Inductive Test Circuit

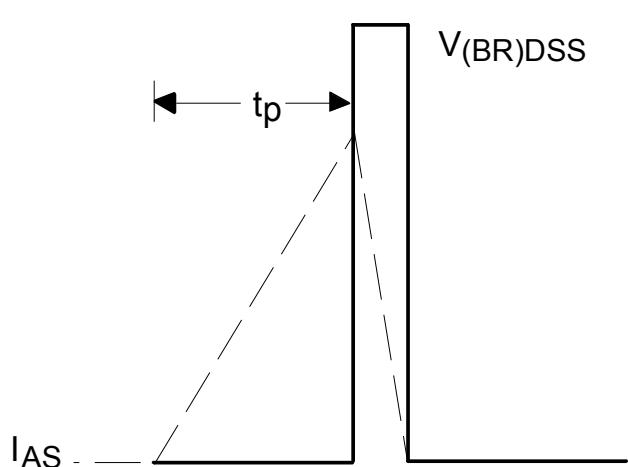


Fig 16b. Unclamped Inductive Waveforms

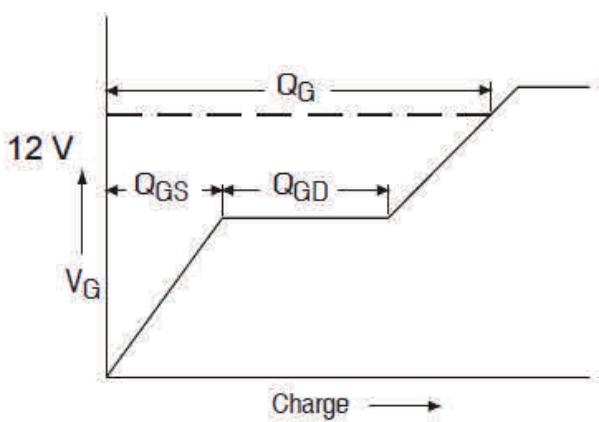


Fig 17a. Gate Charge Waveform

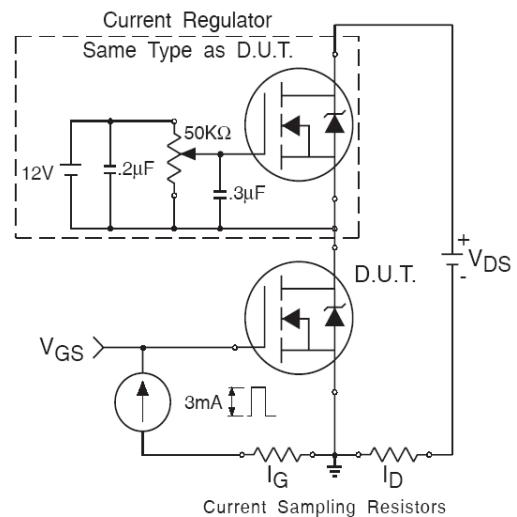


Fig 17b. Gate Charge Test Circuit

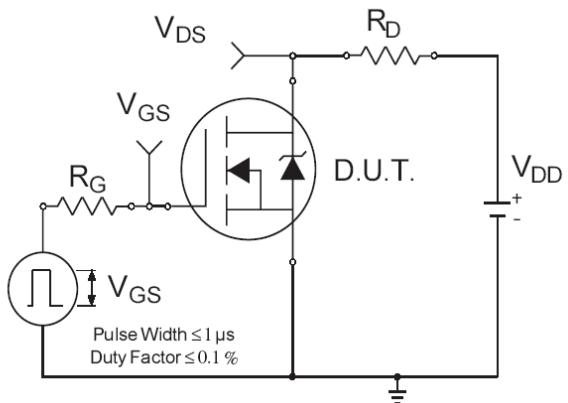


Fig 18a. Switching Time Test Circuit

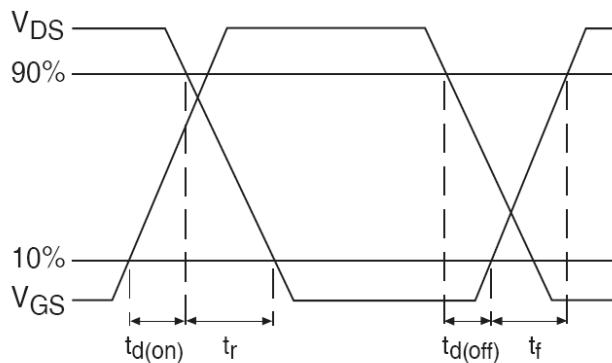
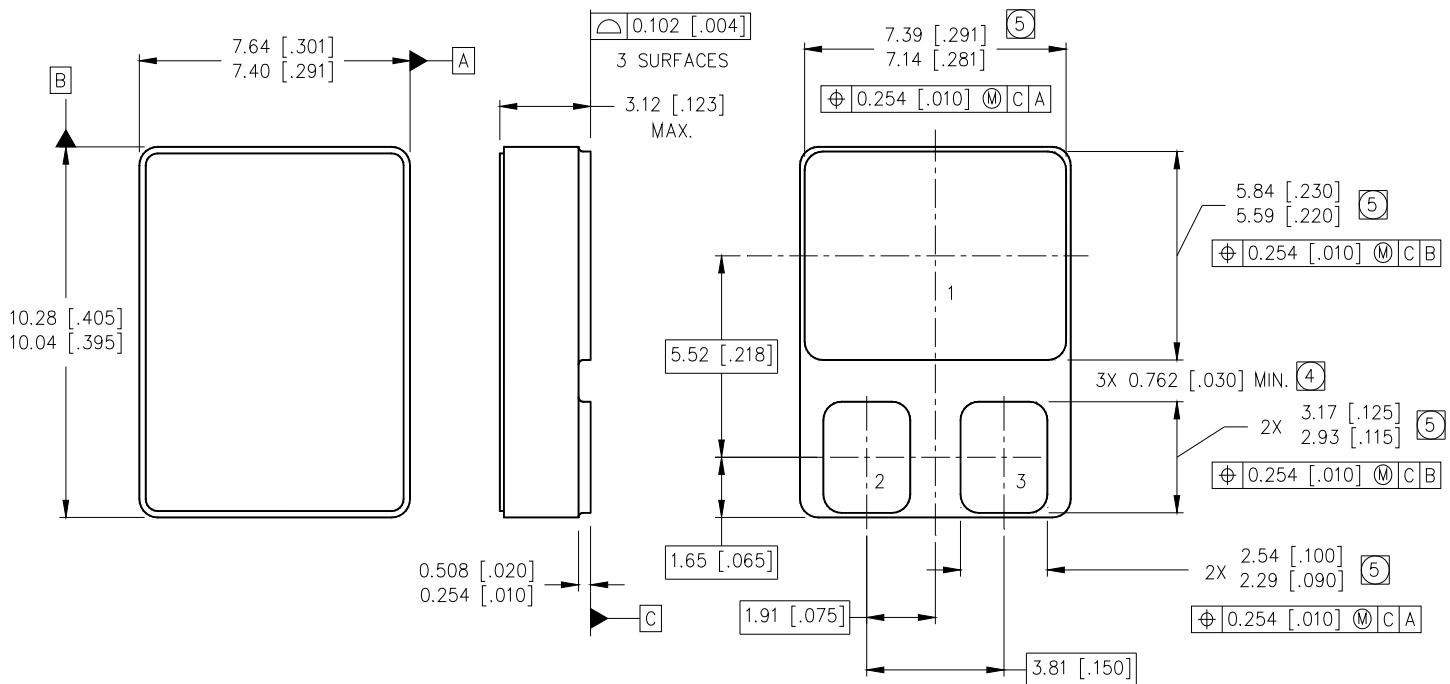


Fig 18b. Switching Time Waveforms

## **Case Outline and Dimensions — SMD-0.5**



## NOTES:

1. DIMENSIONING & TOLERANCING PER ASME Y14.5M-1994.
  2. CONTROLLING DIMENSION: INCH.
  3. DIMENSIONS ARE SHOWN IN MILLIMETERS [INCHES].

**4** DIMENSION INCLUDES METALLIZATION FLASH.

**5** DIMENSION DOES NOT INCLUDE METALLIZATION FLASH.

PAD ASSIGNMENTS

MOSFET		
1	=	DRAIN
2	=	GATE
3	=	SOURCE

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*Data and specifications subject to change without notice.*

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